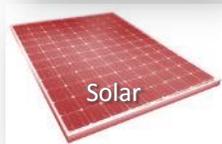


Challenges for Inline Optical inspection in PV: High Performance at High Speed and Low Cost

PV Days 2017 / Fraunhofer CSP,
Session: Metrology and Quality Control in PV

Dr. Christopher Berge
24. October 2017



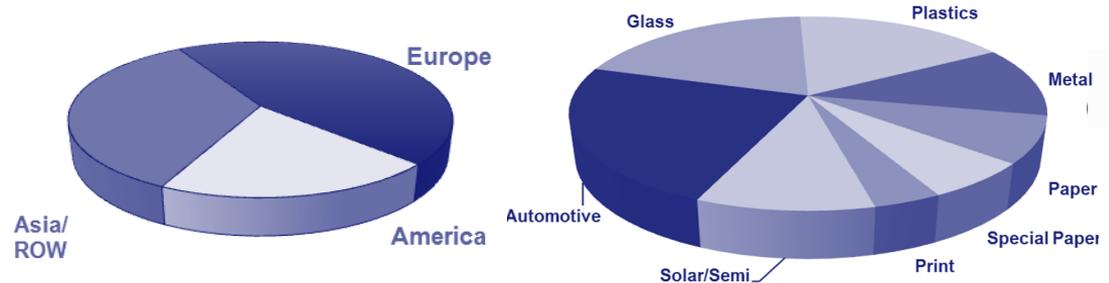
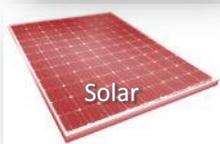
HIGHLIGHTS of ISRA Vision

- › Established 1985
- › Legal form AG, public company
- › Employees > 700 (incl. >100 in China)
- › Sales (16/17) **146.5 mill. €**
- › R&D – Invest ~ 19 mill. € p.a.
- › Equity 159 mill. € >55%



HIGHLIGHTS of ISRA Vision

- › German Company
- › Active in world-wide markets since > 20 years
- › Semi-EL and Solar are strategic markets
- › Long-term growth strategy



Leading world-wide installed Base
- more than 2.600 systems installed



No. 1 in Vision Inspection for Solar Industry

● Inline Systems ● OfflineTools

ISRA VISION / GP Solar

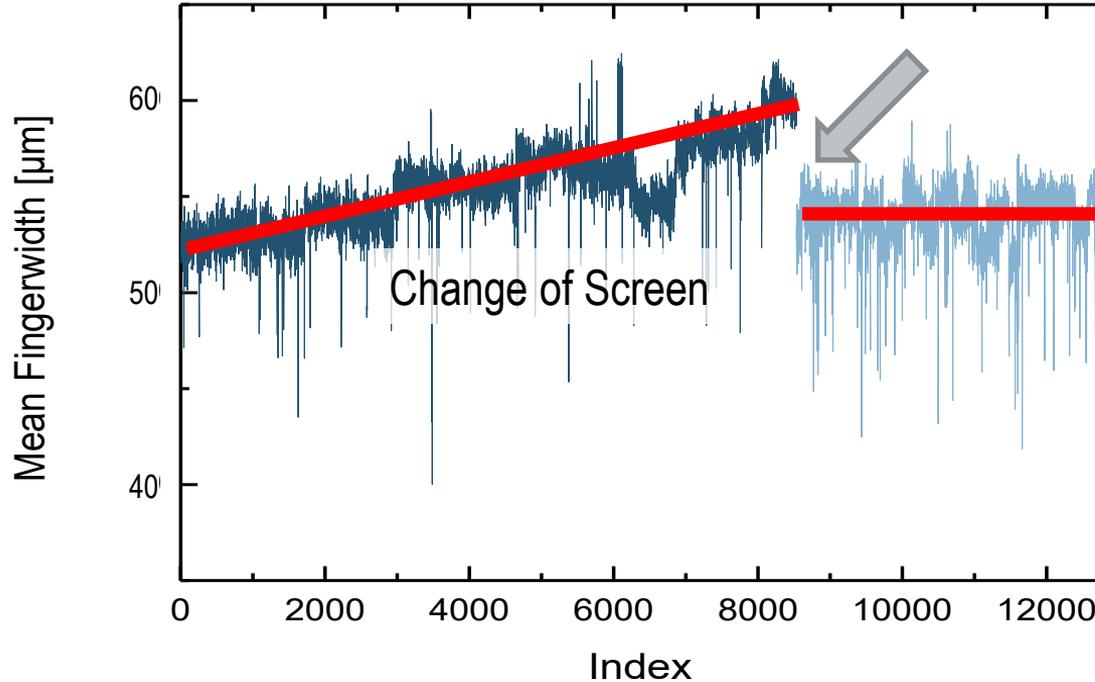
- ▶ Inspection Solutions from > Solar Wafer to Module <
- ▶ Latest solar technology support
- ▶ Inline Inspection integrated in all major automation suppliers world-wide
- ▶ Stand-alone Inspection Solutions

**Already >340 new installations in 2017.
> 8 GW inspection technology for PERC**



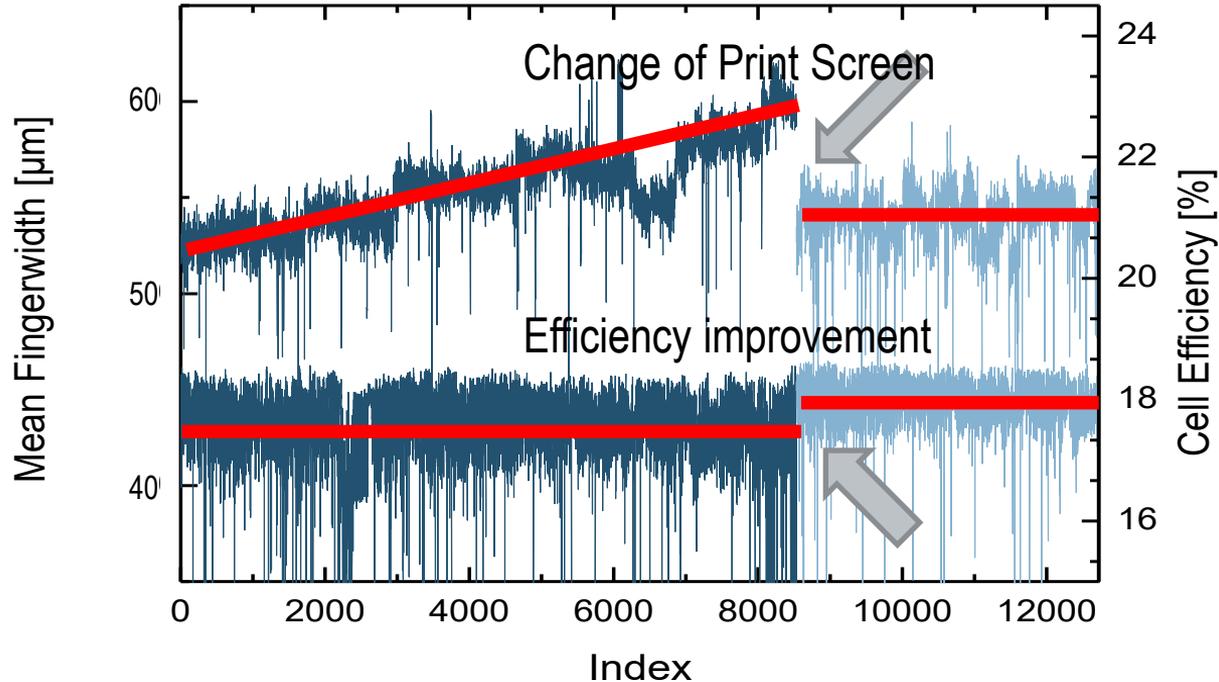
Process Control Benefits

PRINT-Q – Screen Printing Inspection



Bad print screen can be detected by finger width instability.

Is it relevant?



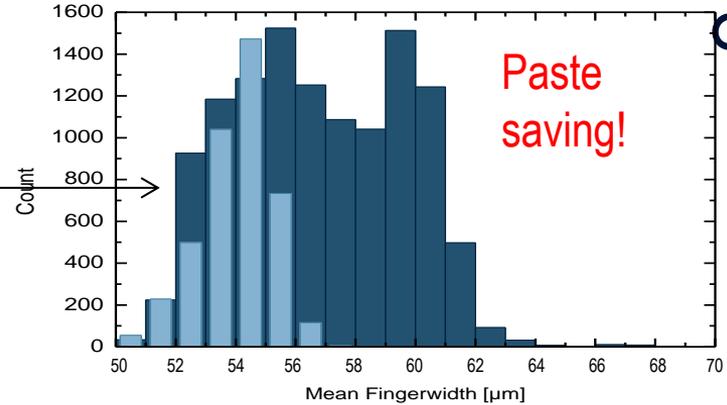
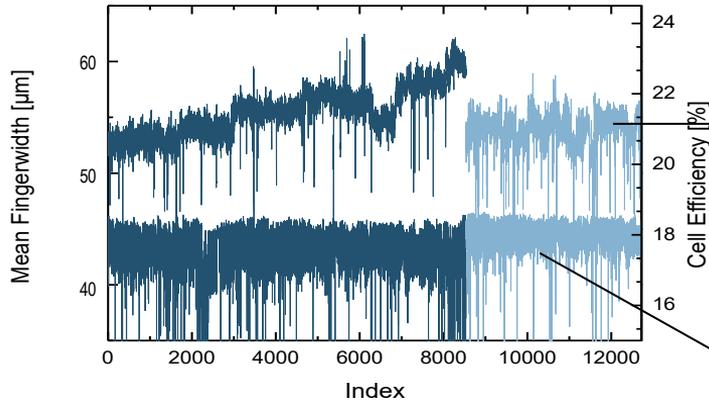
Bad print screen can be detected by finger width instability.

Is it relevant?

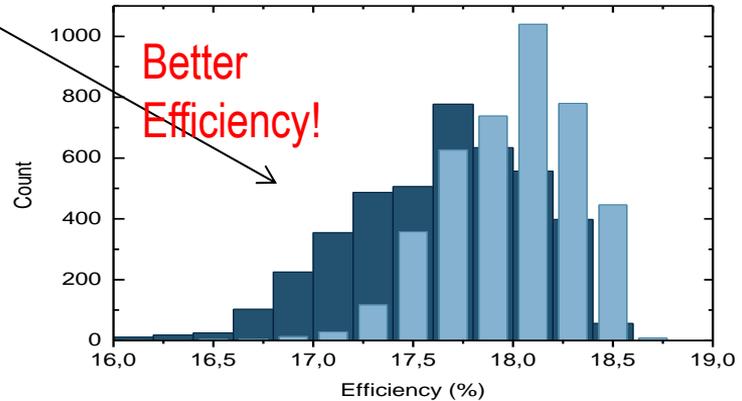
YES IT IS!

Fast Reaction on Process leads to Efficiency improvement

Effect on Fingerwidth & Efficiency



**Inspection can improve
average efficiency**

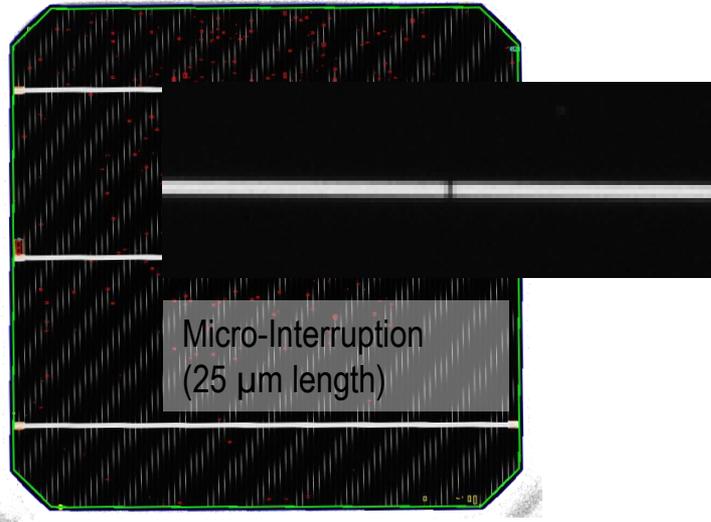


High-Resolution Defect Example: Micro-Interruptions

Print-Inspection of bad cell

Finger width < 50 μ m

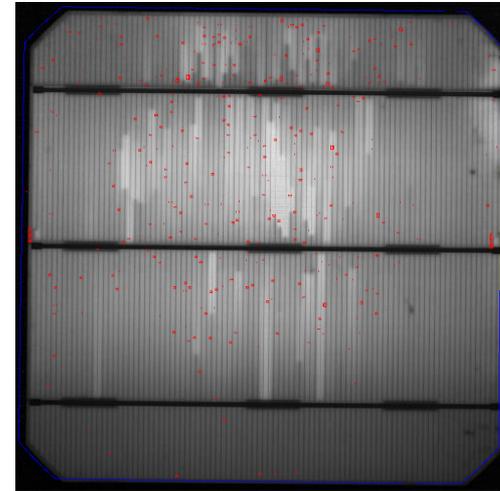
Many micro-interruptions visible (<30 μ m)



PL Rseries Image of bad cell

Overlay of detected interruptions shows:

the micro-interruptions are reason for bad contacting



- High-resolution print inspection PRINT-Q 30M+ can reduce cost structure more than 10%
- improve production at once!



Challenges for Inline Optical inspection in PV

Processing Aspect

New processes - material "looks" different

- ➔ new texturisation approaches
- ➔ Diamond wire cutting of wafers (mono, multi)
- ➔ "DirectWafer" approaches

New cell designs

- ➔ Inspection of new processing steps
- ➔ New critical defects
- ➔ New materials
- ➔ More complex designs/patterns/features

Industry Aspect

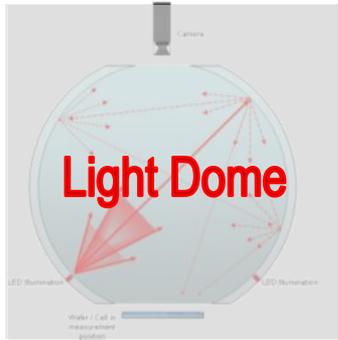
Integrated Multi-GW fabs

- ➔ multiple lines running parallel on same product (sometimes different process equipment)
- ➔ multiple production sites with same quality requirements

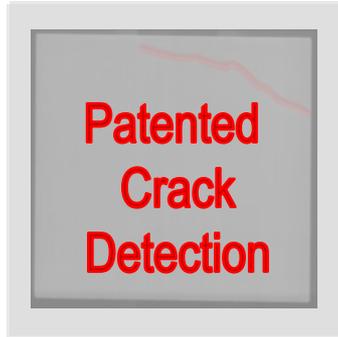
Cost pressure

- ➔ reduced maintenance / operator costs
- ➔ higher availability and productivity (UPH)
- ➔ improve quality, but do not add complexity!

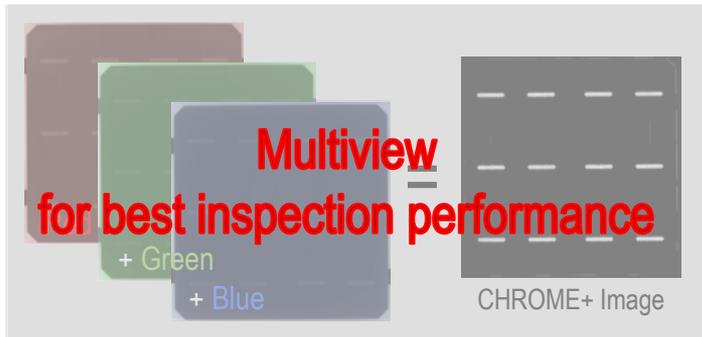
Processing Aspect



Light Dome



**Patented
Crack
Detection**



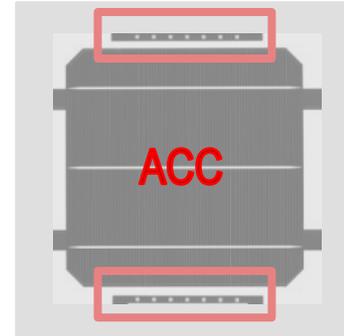
**Multiview
for best inspection performance**

CHROME+ Image

Industry Aspect



**Easy Setup &
Flexible Print
Configuration
Best Usability**



ACC



**Highest
Throughputs
> 4.000 w/hr**



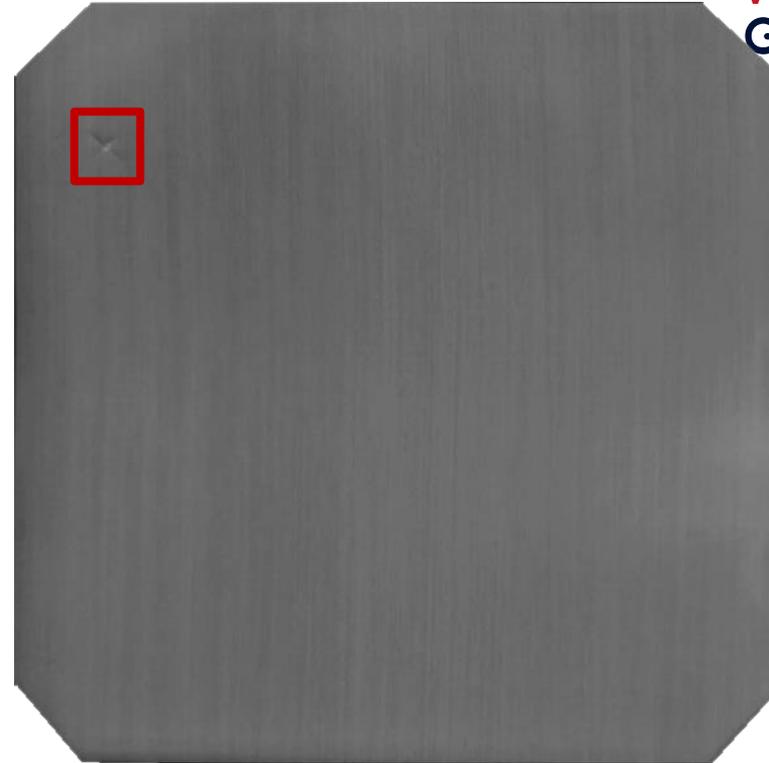
**Copy Exact,
Offline Recipe
Editing &
Central Recipe
Management**

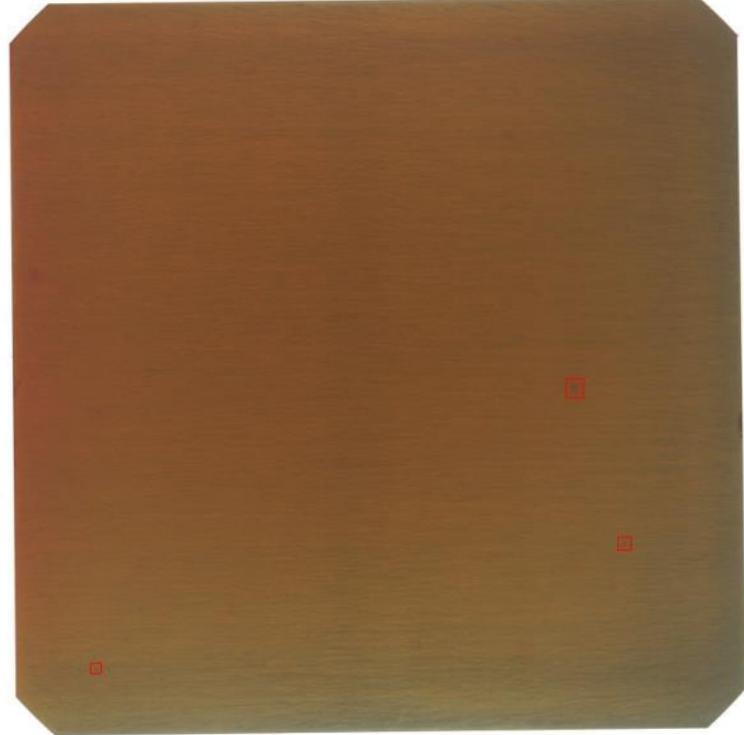
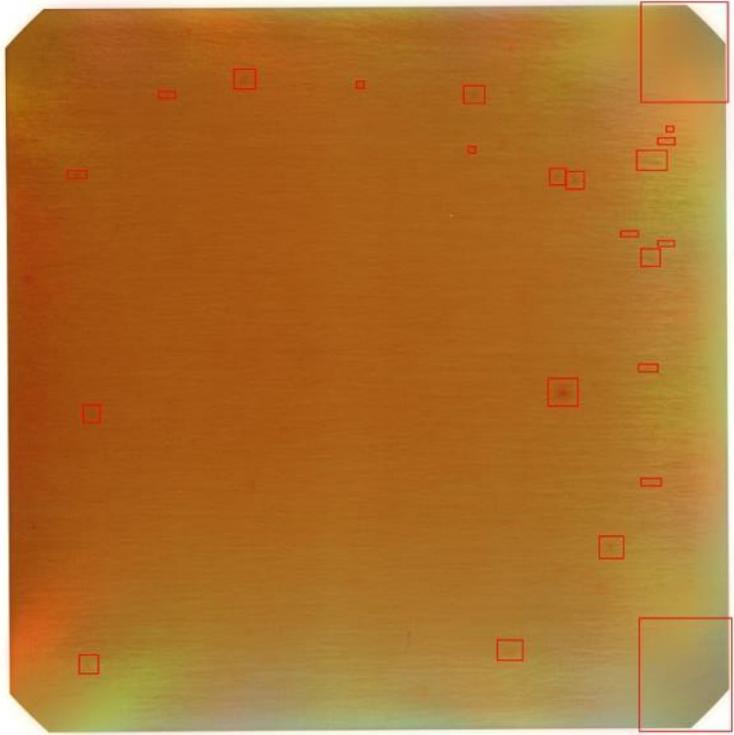
Micro-Crack Inspection on Diamond Wire Cut Wafers

Challenge:

- ➔ anisotropic structure on surface caused by "pilgrim" movement of the cutting wire
- ➔ shiny surface with anisotropic specular reflectance

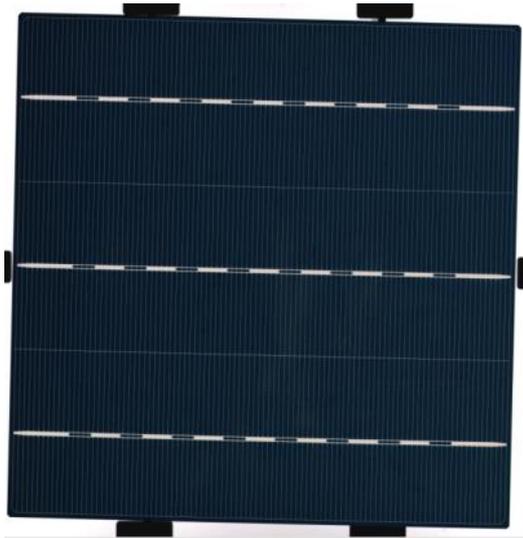
Solved with NANO-D Inspection setup



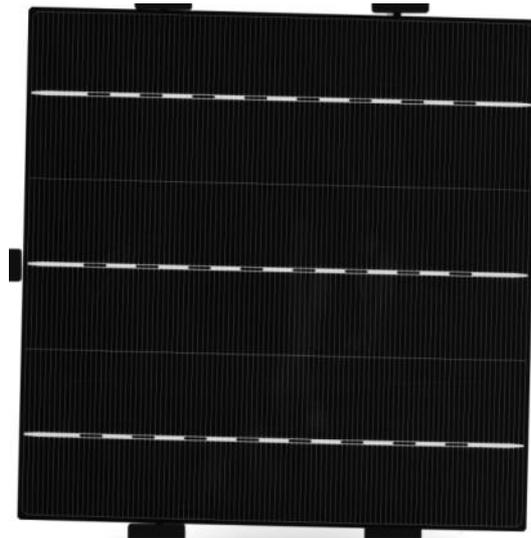


Standard Illumination (left) affected by direct reflexes ("streaks") causing overkill or reduced sensitivity

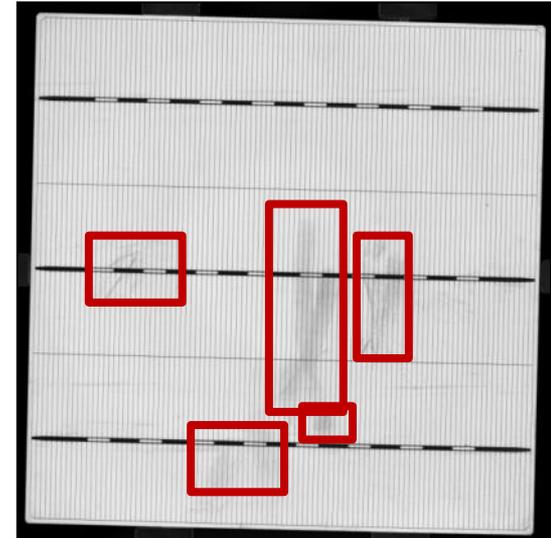
Practical Example



Color Image



Red Image



Saturation Image

Front Side Inspection

Multiple Design Elements - Busbars, Fingers, Closings, Inner Redundancy Lines, ...

Rear Side Inspection

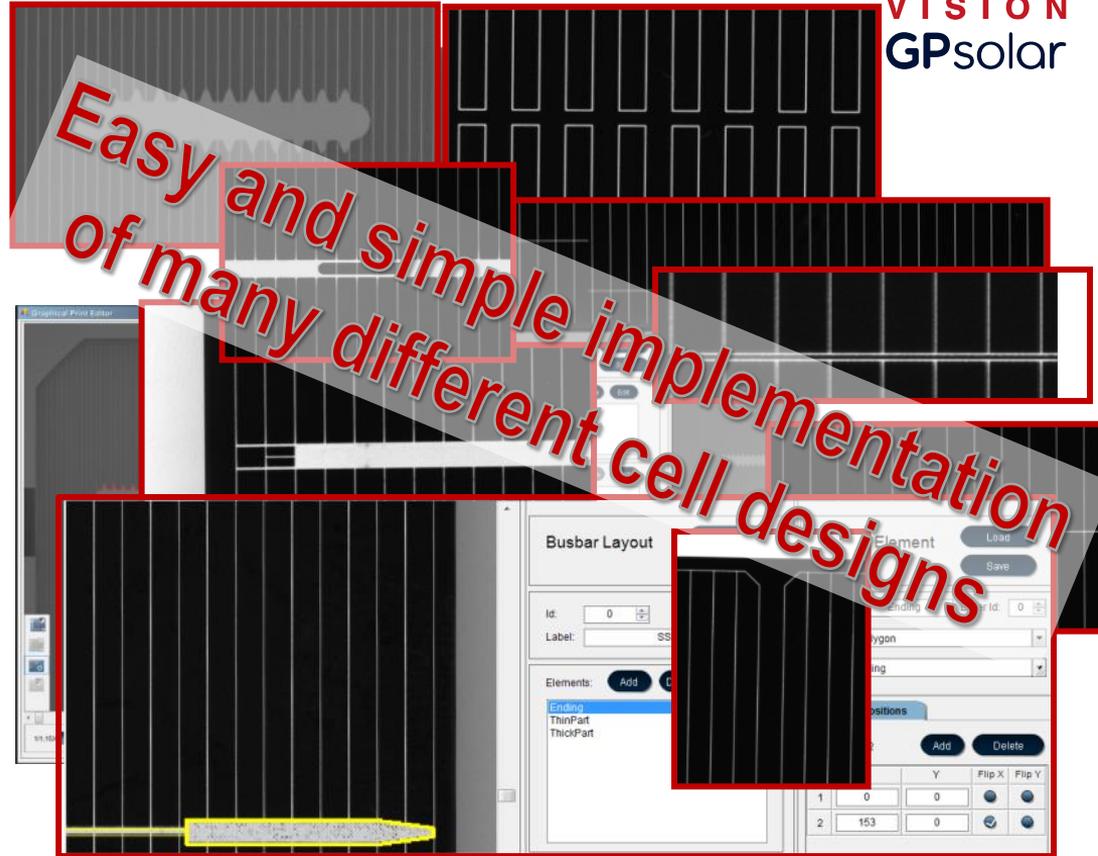
Special Rear Side Busbar Design
Combined with PERC process

Bifacial Cell Designs

Rear side print patterns similar to front,
new inspection features

IBC Cell Designs, HIT structures

**Solved with Advanced Print Editor
in GP Software Suite**



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New cell design

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Industry Aspect

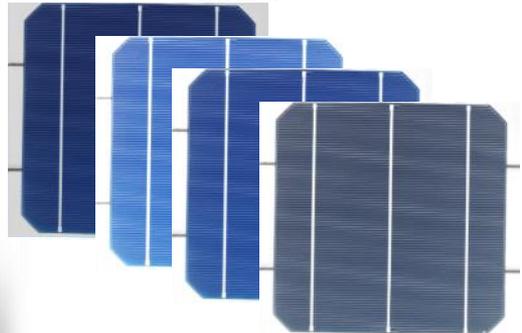
Integrated Multi-GW fabs

- ➔ multiple lines running parallel on same product (sometimes different process equipment)
- ➔ multiple production sites with same quality requirements

Cost pressure

- ➔ reduced maintenance / operator costs
- ➔ higher availability and productivity (UPH)

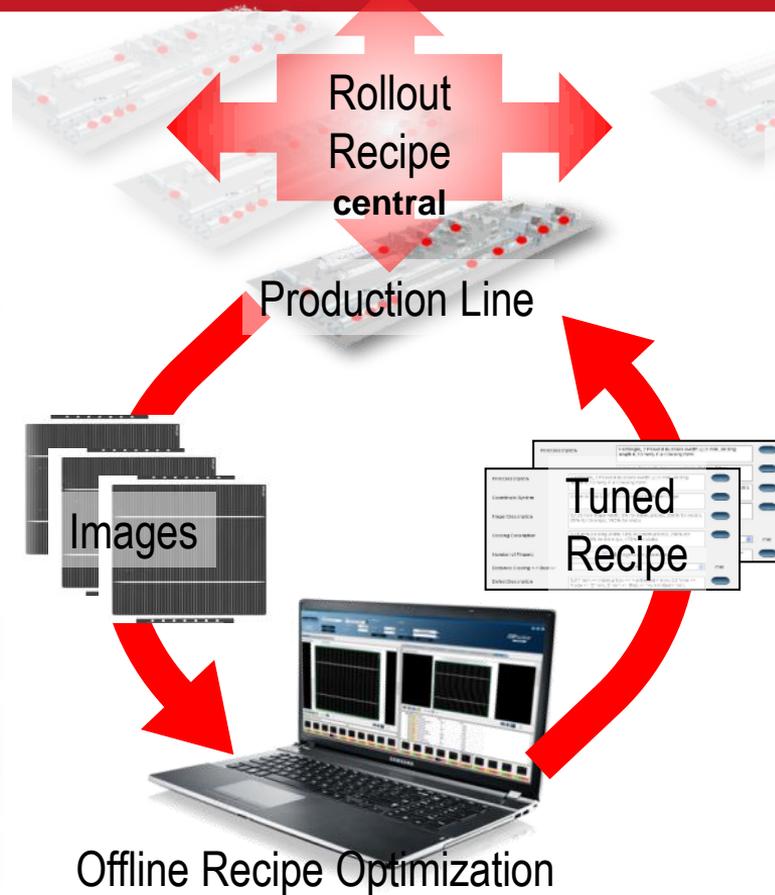
Global Quality with Copy-Exact-Concept - *minimize engineering costs*



**ISRA GP Calibration
generate equal images**



**SAME Quality Sorting,
independent of location:
One Global Standard - Anytime, Anywhere**



- ▶ Save images in the production line
- ▶ Transfer images and recipe to office PC
- ▶ Edit recipe with **Offline Recipe Manager** and test recipe on stored images
- ▶ Transfer **optimized recipe** back to production
- ▶ **Recipe management, version history and centralized rollout** with Central Recipe Tool (CRT)



CRT 2.0 Components

ISRA

Recipe Files
(xml or gp-archive)



Shows all Recipes,
Activities &
Inspection Systems



Download & Execute
Central Recipe



2 Specific Recipe Version



Compare Recipe
two Versions

Specific Recipe Version



Edit and Show
Recipe Version

CRT Server



CRT Client

Offline Recipe Tool

Edit Recipe
Version



Recipe Tool

AutomaticTool

Processing Aspect

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Industry Aspect

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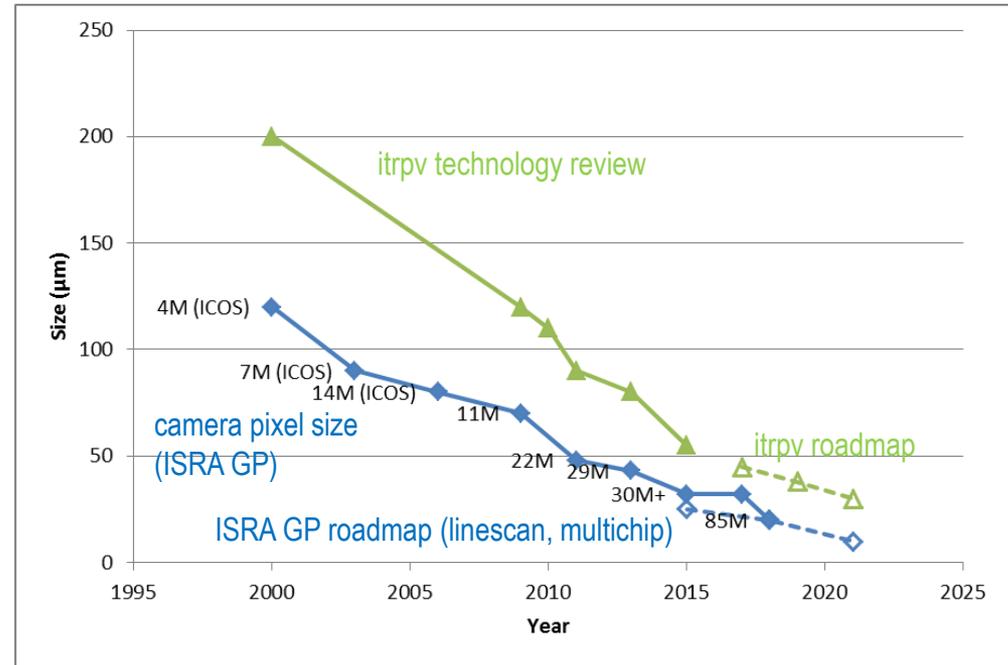
Cost pressure

- ➔ reduced maintenance / operator costs
- ➔ higher availability and productivity (UPH)

Available chip resolutions (matrix camera) scale with target print feature sizes – but price scales with pixels!

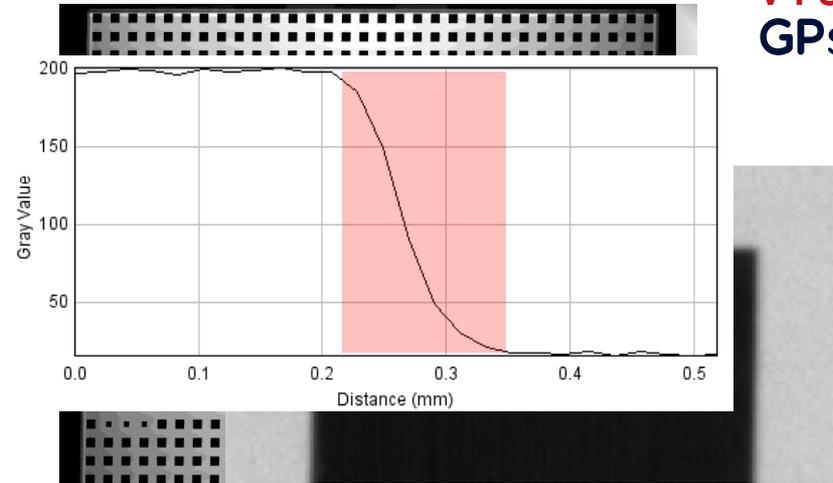
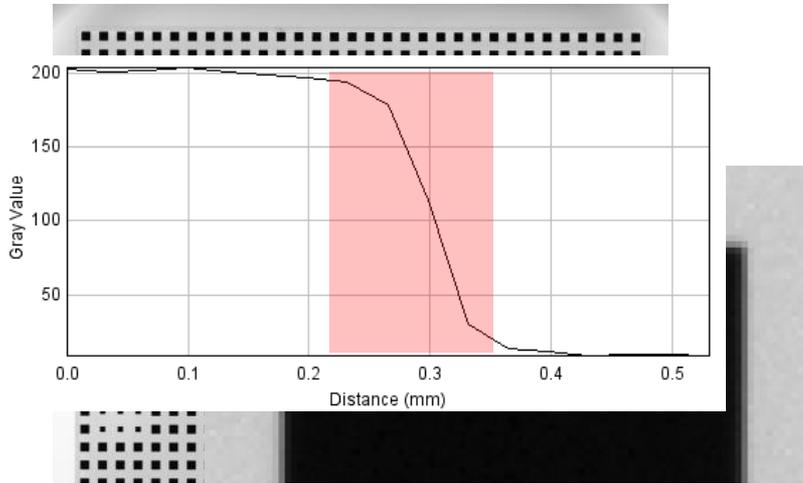
And: the air becomes thinner!

- ➔ Print Sizes drop faster than Matrix Camera Resolutions increase (not talking about costs...)
- ➔ "Defect sizes" (defects to detect) are already smaller than pixel sizes!
 - Status (2017): 32 μm pixel size, interrupts > 40 μm can be detected
 - customers request already <30 μm
- ➔ Good news: 85M camera (20 μm) on the way...
- ➔ but what about the price?
- ➔ What about the amount of data?



More features → Higher resolution → more data to process - at shorter cycle time – for less money!

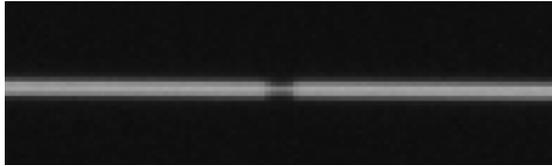
Calibration Target in High Resolution



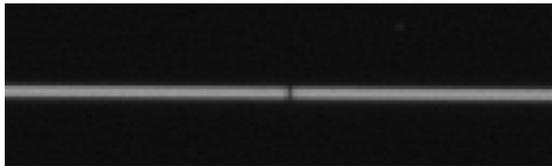
- ▶ Width of transition region is same for both resolutions
- ▶ The additional resolution does not make the transition "sharper"
- ▶ The 30M+ camera already works at the diffraction limit:
 - ▶ higher resolution does not give more information!
 - ▶ We are not yet talking about vibration...

Comparison Line Scan vs. Matrix / Finger Defects

Matrix Image with 25MP
5120 x 5120 / 32 μm pixel size

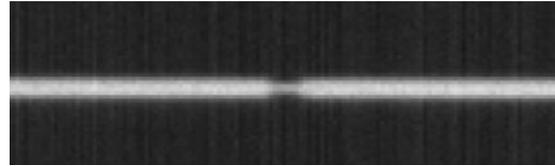


Finger Thinning 50 %
(50 μm width, 150 μm length)

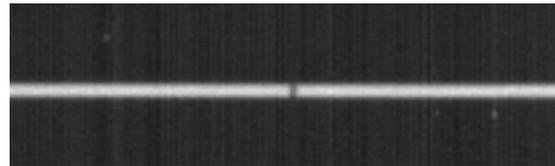


Finger Interruption
(30 μm length)

Linescan Image with 8k / 64M
8192 x 8192 / 20 μm pixel size



Finger Thinning 50 %
(50 μm width, 150 μm length)



Finger Interruption
(30 μm length)

High pixel resolution of Linescan Image does not increase steepness/sharpness of structures, only "smoothing" - same as interpolating!

Both Images without Flatfield Correction. Linescan Image taken on Montech Transport

If camera technology is solved - what else?

High resolution imaging needs "perfect environment"

Exclude vibration of the camera

➔ new machine designs needed?

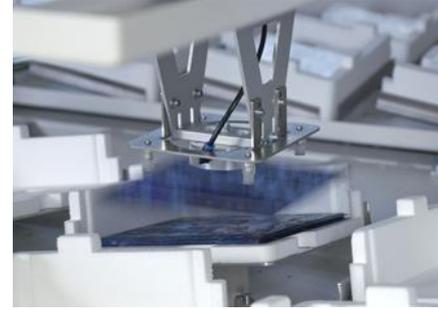


Current Machine Design with integrated inspection

Sources of machine vibration:

Moving handling elements in the machine

- ➔ Flex Pickers
- ➔ Gripper axles with fast acceleration/deceleration
- ➔ Carrier Lifts, Spindle Lifts, ...



Transport Belts in the inspection part

- ➔ Vibration during transport
- ➔ Vibration during standstill

External Vibration

- ➔ even with de-coupled machines, vibration spreads via ground floor



Vibrations are already noticeable with 12M and 30M+ systems!

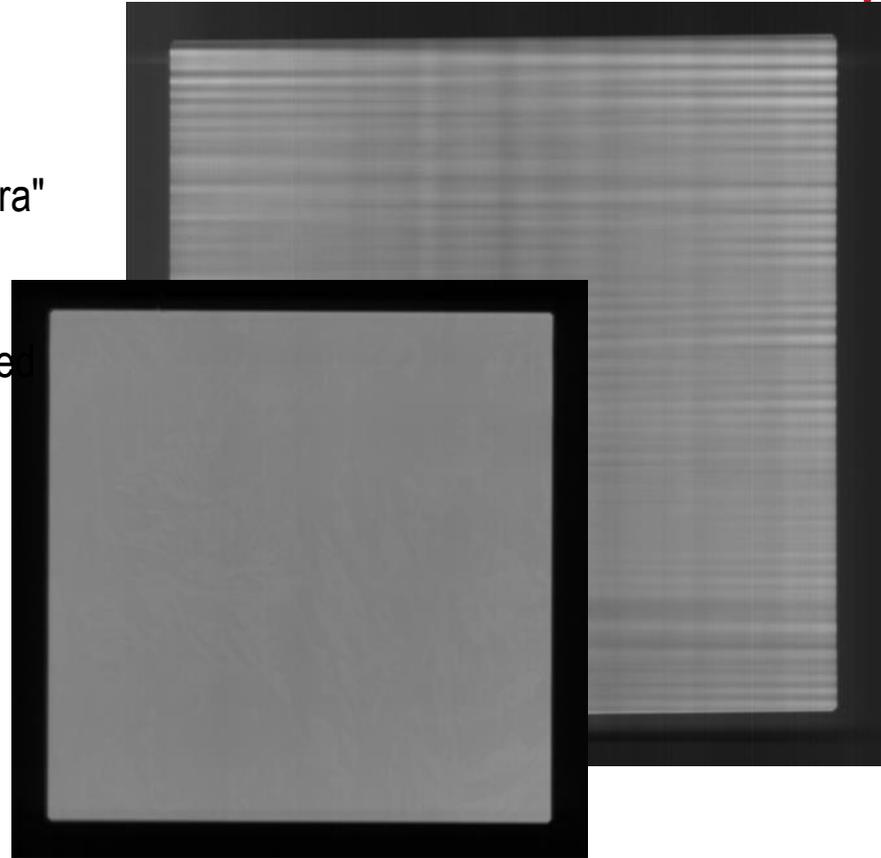
Vibration is no theory...

NANO-D Scan Image

1k IR Camera

Machine vibration during transport causes "zebra" pattern

Scanning when other machine parts are switched off yields perfect scan image



Requirements for "real" $<20 \mu\text{m}$ pixel resolution for inline inspection

Stiff and warp-resistant inspection housing - solved at ISRA GP Solar

Vibration-decoupled inspection unit
(with integrated inspection housing)

- ➔ not connected to any moving parts
- ➔ decoupled from ground floor vibrations

Precision Transport

- ➔ no "motor vibration" during standstill
- ➔ no "after shocks" in the (elastic) belt after stopping
- ➔ precision scanning axes for scan systems

**This is already standard in the semiconductor industry
...with higher costs and lower throughputs**



Joint Effort Required:

Design new machine concepts
together with Handling Suppliers:

- ▶ low vibration, no shock
- ▶ high throughput

New Machine Concepts needed for Solar Industry!

"Low cost linescan" can be more than compensated by "high profile transport"!

Inspection is technically well prepared for current and future technologies.

- ➔ Shorter cycle times and more complex inspection tasks to be addressed by vision suppliers (optimization of inspection algorithms, optimization of inspection hardware)
- ➔ "GW Industry" requirements (central recipe management, reduced maintenance etc) by optimized software concepts and centralized data services

However, cost pressure impacts performance: requirements not reachable with "cheap" systems

Resolution for detection of small defects and inspection of small structures

- ➔ Image quality vs. transport quality / cost / throughput at ultrahigh resolutions (20 μm and smaller)
 - Vibration during image acquisition
 - Precision of Transport for Linescan
 - Transport speed / scanning speed vs. "antireflection coated, dark light trapping samples" - more light!

As always, unknown obstacles may appear unexpected!

- ➔ Early cooperation between customer and supplier R&D at an early development stage

